

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant :	Shingo Eguchi et al.	Art Unit :	2826
Serial No. :	09/925,486	Examiner :	Ahmed N. Sefer
Filed :	August 10, 2001	Conf. No. :	2842
Title :	SEMICONDUCTOR DEVICE		

Mail Stop Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY TO ADVISORY ACTION OF AUGUST 4, 2006 AND FINAL OFFICE ACTION OF
APRIL 10, 2006

Claims 1-27 are pending in this application, with claims 1, 5, 9, 13, 18 and 23 being independent.

Applicants acknowledge with appreciation the Examiner's indication that claims 1-12 and 18-27 are directed to allowable subject matter.

Independent claim 13 and its dependent claims 14-16 have been rejected as being anticipated by Yamazaki (U.S. Patent No. 5,644,147). Dependent claim 17, which depends from claim 13, has been rejected as being unpatentable over Yamazaki. Applicants respectfully traverse these rejections.

Independent claim 13 recites a semiconductor device that includes, among other features, a first electrode, a gate wiring, an insulating film, and a second electrode, "wherein said gate wiring and said second electrode are provided on said same insulating film" (emphasis added). Applicants request reconsideration and withdrawal of the rejection of claim 13 and its dependent claims because Yamazaki does not describe or suggest the recited gate wiring and second electrode being provided on the same insulating film.

As stated in the reply to the Final Office Action of April 10, 2006, Yamazaki describes an electro-optical device that includes: a gate line 208/222, which the Examiner equates to the recited gate wiring; a gate electrode 202, which the Examiner equates to the recited first electrode; and a pixel electrode 218, which the Examiner equates to the recited second electrode. As shown in the marked-up Fig. 3I of Yamazaki attached to this response, the gate line 208/222 and the pixel electrode 218 are not provided on the same insulating film. Rather, the gate line

208/222 is provided on a silicon oxide film 206, and the pixel electrode 218 is provided on a silicon nitride film 217. In the advisory action of August 4, 2006, the Examiner failed to respond to this argument.

For at least these reasons, applicants request reconsideration and withdrawal of the rejections of claim 13 and its dependent claims 14-17.

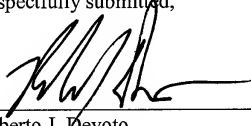
In an effort to ensure productive prosecution of this application, applicants respectfully request an interview with Examiner Sefer to discuss the above-mentioned distinction over the art.

Applicants submit that all claims are in condition for allowance.

The fee in the amount of \$1240 in payment for the Request for Continued Examination fee (\$790) and the Petition for Two-Month Extension of Time fee (\$450) is being paid concurrently herewith on the Electronic Filing System (EFS) by way of Deposit Account authorization. Please apply any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 9/11/06



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